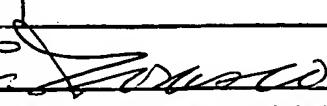


Form PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				ATTY. DOCKET NO. M122-2513	SERIAL NO. 10/805,675			
				APPLICANT H. Daniel Dulman et al.				
				FILING DATE 03/24/04	GROUP 1756			
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name		Class	Subclass	Filing Date If Appropriate
AA		6,312,854 B1	11/01	Chen et al.		1		
AB		6,465,138 B1	10/02	Stanton		1		
AC		5,725,973	03/98	Han et al.		1		
AD		5,563,009	10/96	Bac		1		
AE		4,902,899	02/90	Lin et al.		1		
AP		5,827,625	10/98	Lucas et al.		1		
AO								
AH								
AI								
AJ								
AK								
AL								
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
AM							Yes	No
AN								
AO								
AP								
AQ								
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AR							
	AS							
	AT							
EXAMINER 			DATE CONSIDERED 12/06					
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				FILING DATE Filed Herewith	GROUP Unknown		
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
<i>AS</i>	AA	5,308,721	05/94	Garofalo et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
	AM						Yes
	AN						No
	AO						
	AP						
	AQ						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
<i>AS</i>	AR	Kobayashi, S. et al., "Development of Simplified Process for KrF Excimer Half-Tone Mask with Chrome-Shielding Method",					
		19th Annual BACUS Sympos. on Photomask Technology, Monterey, CA, 9/99, SPIE Vol. 3873 (1999), pp. 288-296.					
<i>AS</i>	AS	Kobayashi, S. et al., "Development of Simplified Process for KrF Excimer Half-Tone Mask with Chrome-Shielding Method					
		(II)", 20th Annual BACUS Sympos. on Photomask Technology, Proceedings of SPIE Vol. 4186 (2001), pp.801-809.					
	AT						
EXAMINER <i>AS</i>		DATE CONSIDERED <i>12/06</i>					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							